

## REMARKS

Formal entry of the Supplementing Amendment is respectfully requested.

This Supplementing Amendment is being filed in follow-up to a telephone conference held with the Examiner on May 2, 2006. At that time, the undersigned representative requested authorization of the Examiner regarding the filing of a Supplementing Amendment for the purpose of submitting a Substitute Specification, which is directed to minor/obvious formal matters including to improve the readability thereof. The Examiner agreed to accept such Supplementing Amendment as long as the issue of new matter does not arise. Also, the Examiner was informed that the Supplementing Amendment would include the additional canceling of claims 15 – 20, which, according to the record, shows that these claims were earlier withdrawn as a result of an election having been made without traverse. This Supplementing Amendment, it is submitted, is in keeping with a telephone understanding reached with the Examiner.

Specifically, regarding the Specification, the originally submitted Specification was revised to correct informalities discovered therein as well as to improve the readability thereof such as with regard to syntax and intent. It is submitted, the revisions implemented thereto do not involve the issue of new matter, either by addition and/or deletion.

A grammatical correction is being effected, also, to the earlier presented replacement Abstract.

Acceptance/formal entry of the present Amendment in supplement to the earlier submitted responsive Amendment of April 25, 2006 in view of the above discussed reasons, as well as reconsideration and early allowance of

the above-identified application in view of the earlier made Amendments in conjunction with the responsive remarks submitted therewith and as supplemented herein is respectfully requested.

To the extent necessary, Applicants petition for an extension of time under 37 CFR §1.136. Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (Case No. 520.43306X00) and please credit any excess fees to such deposit account.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Larry N. Anagnos", is written over a horizontal line.

Larry N. Anagnos

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Attachments

## Appendix B

### Abstract

In a semiconductor integrated circuit device and a semiconductor integrated circuit chip, a circuit forming layer, on which are formed a large number of circuits, is formed on one surface side of a plate-like semiconductor chip, and on the other, opposing surface side thereof, a heat transfer layer is connected therewith in one body. This heat transfer layer is made of a material similar to that of the semiconductor chip, and has formed therein passage ducts to build up a closed flow passage. Within this closed flow passage is enclosed an operating fluid, and there is provided a driving means, such as a resistor film, of the operating fluid. Vibration is given to the operating fluid by the driving means, thereby transferring/diffusing a local increase of temperature generated within the circuit-forming layer.



SUBSTITUTE SPECIFICATION (MARKED-UP COPY)

TITLE OF THE INVENTION

SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE AND SEMICONDUCTOR  
INTEGRATED CIRCUIT CHIP THEREOF

5 BACKGROUND OF THE INVENTION

The present invention relates to a semiconductor integrated circuit device which has wide use, for example, in, being used  
in, such as, electronic equipment and appliances, widely, including  
a computer, etc., ~~for example,~~ and in particular, it relates to  
10 a semiconductor integrated circuit device and a semiconductor  
integrated circuit chip for ~~it~~ the device, which enables being able  
~~to averaging or flattening of the~~ temperature distribution ~~within~~  
~~an~~ inside of an element, through transfer (or diffusion) of heat  
generation within the integrated circuit of such ~~the~~ device  
15 ~~accompanying with the~~ during operation thereof, thereby  
suppressing an increase of local temperature within the  
semiconductor chip of the integrated circuit device.

Conventionally, ~~to be such as~~ according to Patent Document  
1 listed below, a device for diffusing (or transferring) the heat  
20 from a heat generating body, such as, a semiconductor or the like,  
which is mounted on the electronic equipment, is provided, for  
example, with a heat diffusing panel or plate ~~is already known~~  
~~in the following Patent Document 1, for example,~~ wherein a loop-like  
groove is formed on a contacting surface of each of an upper plate  
and a lower plate of high heat-conductive material, and in which  
25 ~~both of these plates are connected while by~~ laying one on ~~the top~~  
of another, so that the said loop-like grooves are opposing to  
each other, thereby building up a heat pipe within an inside thereof.

~~Also, in general~~ Generally, as a device for transferring heat from the heat generating body, it is also ~~already~~ known that the heat can be transferred ~~by the fact of~~ through driving a fluid enclosed within an inside thereof, for example. In the device disclosed in the ~~following~~ below-listed Patent Document 2, for example, ~~for the purpose of the~~ transferring of the heat from a printed circuit board, on which a plural number of semiconductor devices or elements (i.e., the heat generating bodies) are mounted, ~~with~~ is effected through the provision of an electrical heating means, which is formed in a part of the liquid flow passage formed and is built up with a capillary, ~~the~~. The liquid within an inside of the capillary is heated ~~up~~, reaching boiling temperature, which causes pulse-like abrupt action of the liquid in a pulse-like manner, thereby boiling it abruptly (i.e., generating bumping), thereby driving the liquid ~~mentioned above~~, due to a sudden increase of pressure accompanying evaporation when generating the bumping.

However, the principle of transferring the heat with using such vibration of the liquid is described, in more detail, such as, in the ~~following~~ below-listed Non-Patent Document 1.

Also, in the below-listed ~~following~~ Non-Patent Document 2, ~~in particular~~ particularly, in Figure 10 thereof, there is disclosed ~~the~~ a structure for diffusing the heat generated from ~~the~~ a semiconductor chip having a large electric power consumption therein, ~~by using a vessel or container building up thereinto~~ thereby achieve a device for transferring the ~~heart with~~ heat through utilizing the vibration of the heat pipe and/or the liquid.

[Patent Document 1]

Japanese Patent Laying-Open No. 2002-130964 (2002)

[Patent Document 2]

Japanese Patent Laying-Open No. Hei 7-286788 (1995)

[Non-Patent Document 1]

"Enhancement of Heat Transfer by Sinusoidal Oscillation of Fluid (Transient Behavior of a Dream Pipe)" (pp 228-235), by Mamoru OZAWA and 5 others, Vol. 56, No. 530 (1990-10), a collection of papers of Japan Machinery Institute (B-Edition)

[Non-Patent Document 2]

Z.J. Zuo, L.R. Hoover and A.L. Phillips, "An integrated thermal architecture for thermal management of high power electronics", pp 317-336, Suresh V. Garimella, Thermal Challenges  
10 in Next Generation Electronic System (PROCESSING OF INTERNATIONAL CONFERENCE THERMES 2002), FANTA FE, NEW MEXICO, USA, 13-16 JANUARY 2002

~~By the way, in~~In recent years, for ~~the~~highly integrated semiconductor chips, ~~being of the type~~ used for calculation  
15 ~~processing, such as, in the computer, etc., for example, great~~ demands ~~are have been made strongly, not only upon for achieving~~ significant improvements in ~~small-sizing the down-sizing~~ of the chip-die size thereof and also in the ~~speed~~speed-up of calculation processing ~~much more, but,~~ also, on reduction of electric power  
20 density per a chip, ~~accompanied with a demand on for~~ lower electric power consumption. ~~For satisfying both of them~~In order to satisfy these demands, an improvement is made ~~up on a~~ technology of mounting a logical element and a memory element within the same chip (commonly named "System On-Chip"), for example.

25 In such ~~the~~semiconductor chip, ~~since the~~memory element portions, each being smaller in the electric power density ~~comparing compared~~ to that of the logical element, are mounted on the same semiconductor chip with the logical elements, ~~mixing up together with, therefore~~ Because of the mixing elements with  
30 different power requirements, the electric power density per a such chip is smaller ~~comparing compared~~ to that of the conventional

semiconductor chip. However, ~~seeing the in a~~ semiconductor chip of the former as a whole, a large difference ~~is exists in the~~ locally generated ~~of the~~ electric power consumption ~~within of~~ different portions of the chip. Further, in a portion of the logical element(s), there is also produced a distribution of the electric power density, and, as a result thereof, there is also generated a large difference in the electric power density within the chip.

Since the difference of the electric power density appears to be the difference of the heat generation density, ~~as it is,~~ in the semiconductor chip, a large temperature distribution is generated, when operating such the chip, on which are mounted both mounting the logical elements and the memory elements. For example, there may be within the same chip, in more details, such as, a local increase of temperature (so called, a "hot spot") within the logical element portion(s). And, if such the hot spot comes up to reaches an upper limit of junction temperature of a transistor, it causes thermal runaway of the semiconductor element; therefore, it is necessary to provide any means or measure for dissolving such the hot spot. Also, the generation of such the hot spot results in is a great reason ~~of for~~ reducing an operation permissible temperature (i.e., the maximum temperature permissible for the package, so as to guarantee a normal operation of the circuits of the semiconductor chip mounted within that package) of the integrated circuit package mounted on the said semiconductor chip. For this reason, an entire ~~of the~~ cooling structure comes thereof is sized to be large. Therefore, ~~in the sized thereof,~~ and therefore it is impossible to apply it into a small-size computer and/or a small-size electronic appliance and, in particular, to such a unit that is being necessary to be portable, such as, being called by a "desk top" type or a "note-size" type, and also to apply it into a computer, in which the integrated circuit packages are mounted in a plural number thereof with high density, such as, with regard to being called by a "rack mount server" and/or a "blade server", etc.

~~On the contrary~~ Contrary to this, for example, with ~~such the~~  
a heat transfer or diffusing mechanism as that shown in the Patent  
Document 1 and/or the Patent Document 2, mentioned above, such  
~~the~~ structure is adopted therein, that the semiconductor elements  
5 (i.e., chips), being which constitute the heat generating body,  
are attached on the ~~said~~ heat diffusing plate through a high heat  
conductive grease, a high heat conductive adhesive, or a high heat  
conductive rubber, etc. For this reason, in the case when ~~the a~~  
hot spot is generated within said heat-generating parts, ~~this the~~  
10 hot spot is diffused into the heat diffusing plate through the  
grease, ~~the~~ adhesive or ~~the~~ rubber, which is thermally connected  
to ~~that the~~ heat generating parts, directly. By the way, ~~such the~~  
high heat conductive grease, ~~the~~ adhesive or ~~the~~ rubber has ~~the~~  
a thermal conductivity of an order of  $10 \text{ W/(m} \cdot \text{K)}$ , at the highest,  
15 but, even in the case of the largest one, ~~but~~ this is still remarkably  
small ~~comparing compared~~ to the thermal conductivity of metal or  
a semiconductor, such as, aluminum or silicon (which is in an order  
of  $100 \text{ W/(m} \cdot \text{K)}$ , for example). For this reason, with such ~~the a~~  
structure, in which the semiconductor chips, being the heat  
20 generating parts, are attached onto the heat diffusing plate  
through the grease, the adhesive or the rubber, relating to the  
conventional art, there still remains a problem that a large  
difference of temperature occurs within the semiconductor chip  
due to the hot spot.

## 25 BRIEF SUMMARY OF THE INVENTION

~~Then, according~~ According to the present invention, which  
takes into being accomplished by taking such consideration the  
problems and/or limitations of the conventional arts techniques  
mentioned above into the consideration, and in more details thereof,  
30 it is an object thereof is to provided a semiconductor integrated  
circuit device and a semiconductor integrated circuit chip for  
it, wherein the "hot spot" can be reduced, ~~which the "hot spot"~~  
is generated within the semiconductor chip due to the small-sizing

of the chip and/or the difference in the electric power density, so as to suppress or flatten the difference in the heat distribution generated within the semiconductor chip, but without lowering the permissible temperature of the integrated circuit package mounting the semiconductor chips thereon, and, as a result of this, enabling the small-sizing and light-weight of the cooling structure as a whole, with ease.

Namely, according to the present invention, for accomplishing the object mentioned above, there is provided a semiconductor integrated circuit chip, ~~being made of~~ formed as a plate-like semiconductor chip, comprising: a circuit forming layer, on which a plurality of circuits are formed, being formed on one surface side ~~surface~~ of the plate-like semiconductor chip; ~~in which a plural number of circuits are formed;~~ and a heat transfer layer, being connected with the plate-like semiconductor chip in one body, being formed on another, opposing surface side of the semiconductor chip, on other side surface opposing to that where said circuit forming layer is formed, wherein said heat transfer layer is made of a material similar to that of said semiconductor chip, and comprises, in an inside thereof: a closed flow passage; an operating fluid hermetically enclosed within said closed flow passage; and driving means of said operating fluid. ~~the followings.~~

Further, according to the present invention, in the semiconductor integrated circuit chip, as described in the above, both said plate-like semiconductor chip and said heat transfer layer are made of a material of silicon, or said driving means of the operating fluid is made of means for giving vibration to said operating fluid hermetically enclosed within said closed flow passage, or said vibration giving means ~~is made up with an~~ includes a resistor layer. The Or, said resistor layer is may be disposed in a region where heat generation density is lower than an averaged average of heat generation density of said integrated circuit chip as a whole.

Also, according to the present invention, in the semiconductor integrated circuit chip, as described ~~in the above~~, said operating fluid is water, or said plate-like semiconductor chip is ~~of such a~~ a type of chip, wherein logic elements and memory elements are formed separately within the one surface side ~~surface~~ thereof, on which the circuits are formed.

Also, according to the present invention, in the semiconductor integrated circuit chip, as described ~~in the above~~, possibly, ~~the~~ a plurality of closed flow passages, being formed ~~in said heat transfer layer, are be formed in a plural number thereof,~~ along with one at said another surface side of said semiconductor chip, and each of the plurality of closed flow passages ~~formed in the plural number thereof~~ has the means for driving the operating fluid enclosed within an inside thereof, independently, and further comprising a ~~plural number~~ plurality of temperature detecting means ~~are provided~~ within said semiconductor chip, wherein ~~said plural number~~ a plurality of driving means are provided independently and are controlled depending upon in dependence on temperature detection outputs from said temperature detecting means. ~~Or alternately,~~ Alternatively, it is also possible that the semiconductor integrated circuit chip, as described ~~in the above~~, further comprises another other plural number of closed flow passages, being passage which is formed along with other at a same surface side of said semiconductor chip as said plurality of closed flow passages, crossing over ~~the plural number said plurality of said closed flow passages formed~~, and, further, each of said plurality of closed flow passages ~~formed in the plural number thereof~~ has a means for driving the operating fluid enclosed within an inside thereof, independently, and moreover, further comprising a ~~plural number~~ plurality of temperature detecting means which are provided within said semiconductor chip, wherein ~~said plural number of driving means, which are provided independently for the plural closed flow passages, respectively,~~ are controlled depending upon in dependence on temperature detection outputs from said temperature detecting means.

And, also, according to the present invention, for accomplishing the object mentioned above, there is provided a semiconductor integrated circuit chip, comprising: a plate-like semiconductor chip; a circuit forming layer, being formed on one surface side ~~surface~~ of said plate-like semiconductor chip, on which a ~~plural number~~ plurality of circuits are formed; and a heat transfer layer, being formed on ~~either another surface side surface~~ opposing to of the semiconductor chip, opposite the side surface on which said circuit forming layer is formed and connected therewith in one body, for suppressing a local increase of temperature caused due to heat generation of the circuit within said circuit forming layer of said semiconductor chip, ~~being connected therewith in one body~~.

In addition to the above, according to the present invention, there is further provided a semiconductor integrated circuit device, comprising: a semiconductor integrated circuit chip, in a part of which are formed a plurality of circuits ~~in a plural number thereof~~; a mounting board, in a part of which are formed wiring patterns, for mounting said integrated circuit chip thereon; a case for receiving said mounting board, on which said integrated circuit board is mounted, in an inside thereof; and ~~a plural number~~ plurality of terminals, being planted outside from said case or said mounting board, and being electrically connected to the circuits formed on said semiconductor integrated circuit chip, wherein said semiconductor integrated circuit chip is ~~such the~~ a type of semiconductor integrated circuit chip as described in the above.

And, according to the present invention, the semiconductor integrated circuit device, as described in the above, further comprises a heat sink, being attached on a part of an outer surface of said case, or the electric power to be supplied to said driving means, which is formed in said heat transfer layer of said semiconductor integrated circuit chip, is a part of the electric power to be supplied to said semiconductor integrated circuit chip

through said terminals of said semiconductor integrated circuit device.

#### BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWING

Those and other objects, features and advantages of the present invention will become more readily apparent from the following detailed description when taken in conjunction with the accompanying drawings wherein:

Fig. 1 is an enlarged cross-section view of a part of a semiconductor integrated circuit chip, according to one embodiment of the present invention, in particular for showing the details of a driving means thereof;

Fig. 2 is a view for explaining the condition of mounting the semiconductor integrated circuit device onto an appliance, which comprises the semiconductor integrated circuit chip therein, according to the one embodiment of the present invention;

Fig. 3 is a cross-section view for showing the internal structure of the semiconductor integrated circuit device, in which the semiconductor integrated circuit chips are installed, according to the embodiment of the present invention;

Fig. 4 is a perspective view for showing an outlook and the internal structure of the semiconductor integrated circuit chip, according to the embodiment of the present invention;

Figs. 5(A) and 5(B) are a side view and an upper view of the semiconductor integrated circuit chip, according to the embodiment of the present invention, in particular, being seen from directions of arrows A and B shown in Fig. 4, mentioned above;

Fig. 6 is a view for showing ~~other~~ another example of a passage duct formed on a flow passage (heat transfer) substrate in the

semiconductor integrated circuit chip, according to the present invention; and

Fig. 7 is also a view for showing further other example of the passage duct formed on a flow passage (heat transfer) substrate in the semiconductor integrated circuit chip, according to the present invention..

#### DETAILED DESCRIPTION OF THE INVENTION

Hereinafter, embodiments according to the present invention will be fully explained by referring to the attached drawings.

10 In Fig. 2 ~~attached herewith of the drawings~~ is shown an outlook of the semiconductor integrated circuit device, according to the present invention (including also an exploded view of a part thereof). Namely, as is apparent from the figure, the semiconductor integrated circuit device 100 is made of up with, such as, a ceramic  
15 of high heat conductivity, for example, wherein a package case 105, having an forming an about cubic external shape thereof that is substantially cubic, and a printed circuit board (a mounting board) 103 are piled up on each other, thereby defining a closed space therebetween, and within an inside thereof is mounted a  
20 semiconductor chip 101, being which is a circuit element made from a rectangular silicon plate, for example. Also, this semiconductor ~~chip chip~~ 101 is mounted on the printed circuit board (the mounting board) 103 and connected electrically therewith. And, through the printed circuit board 103, the circuits (for example, a CPU and/or  
25 a memory, etc.) formed within the semiconductor chip 101 are electrically connected to a plural ~~number of~~ external terminals 201, which are provided for electrical connection thereof to an outside, but not shown in the figure herein.

Also, as is shown in the figure, the semiconductor integrated  
30 circuit device 100, mentioned above, according to the present invention, is attached with a heat sink 300 for heat radiation

on an upper surface thereof, for example, ~~under the condition of being such where~~ the package case 105 is located, and further ~~it~~ the semiconductor integrated circuit device is mounted at a predetermined position within a cabinet (or a housing) 400 of a server, etc. ~~Or, alternately~~ As an alternative, without being attached ~~with to~~ such the heat sink as was mentioned above, ~~it~~ the semiconductor integrated circuit device may be installed as ~~it~~ is within the electronic appliance, including the personal computer of the portable type, for example.

Also, the cross-section view in Fig. 3 shows the condition where the semiconductor chip 101, mentioned above, is mounted on the printed circuit board 103, on the lower surface of which are planted a ~~plural number~~ plurality of pins (i.e., external terminals) 201, in the semiconductor integrated circuit device 100 according to the present invention shown in Fig. 2. However, in the figure, the same reference numerals given to those shown in Fig. 2, mentioned above, indicate the similar constituent elements thereof, and a reference numeral 104 in the figure is a high heat-conductive grease, a high heat-conductive adhesive, or a high heat-conductive rubber, which is inserted between the semiconductor chip 100 and the package case 105.

Next, Fig. 4 ~~of the drawings attached herewith~~ shows the detailed structure of an integrated circuit board covering an area bounded by broken lines, being corresponding to the semiconductor chip (i.e., a chip-die) 101, which is mounted on the semiconductor integrated circuit device 100, according to the present invention mentioned above. Namely, in the figure, the lower surface side ~~surface~~ of the integrated circuit board 1, being the semiconductor chip 101 mentioned above, is a layer, on which a large number of circuits are formed for building up a logic element (i.e., a CPU) and/or a memory element (i.e., a memory), separating formed in separate from the regions thereof, respectively, within the same chip, by applying therein the "System On Chip" technology mentioned above, for example, through ~~the a~~ known manufacturing method of

the semiconductor device~~+~~. Such layer is a thus, being so-called  
an electronic circuit (or electronic circuit forming) layer 2.

On the other hand, ~~upon on~~ an upper surface side-surface  
of the integrated circuit board 1, being the semiconductor chip  
5 101 mentioned above (i.e., the opposite surface to the electronic  
circuit layer 2 on the chip-die), there is formed a closed flow  
passage through a ~~plural number~~ plurality of passage ducts 3, being  
integrated in one body together with the said chip (i.e., the  
chip-die), and an operating fluid 4 is hermetically enclosed within  
10 an inside thereof. Also, in the vicinity of one end portion of  
~~the~~ each passage duct 3 is formed a resistor film 5 for building  
up a driving means of the operating fluid, while at the other end  
portion of ~~the~~ each passage duct 3 is formed a buffer 6, to be  
a space for communicating with each other.

15 Fig. 5(A) shows the condition of the integrated circuit board  
1, being the semiconductor chip 101, as seen from the direction  
of an arrow A shown in Fig. 4 ~~mentioned above~~. However, in this  
figure, a reference numeral 102 ~~indicates a~~ represents solderballs  
which are inserted between the electronic circuit layer 2 of the  
20 integrated circuit board 1 and the mounted board 103. Also, Fig.  
5(B) shows the condition of the integrated circuit board 1, being  
the semiconductor chip 101, ~~but as~~ as seen from the direction of an  
arrow B shown in Fig. 4. ~~mentioned above~~.

As is apparent from ~~these~~ these figures, on the integrated  
25 circuit board 1, ~~of~~ being the semiconductor chip 101, the passage  
ducts and the buffer portions 6 are formed in a plural number thereof,  
in a comb-like shape; on the surface side-surface opposing to the  
electronic circuit layer 2, along with one side of the board (i.e.,  
a horizontal side of the semiconductor chip, in the example shown  
30 in Fig. 5(B) mentioned above), and within an inside thereof is  
hermetically enclosed a fluid (i.e., the operating fluid 4) having  
a large latent heat, such as, a water or the like, for example.  
Also, at an end portion or on a surface in the vicinity of those

passage ducts 3, opposing to the side, on which the buffer portions 6, mentioned above, are formed, there are formed the resistor films 5 for building up the driving means of the operating fluid, at resistor films 5 having a width ~~being~~ equal to or a little bit larger than that of the passage duct, respectively. Namely, each of the resistor films 5 is in contact with the operating fluid 4, which is hermetically enclosed within the inside of the passage duct 3 (see Fig. 5(A)). Further, ~~with the driving means of the operating fluid, mentioned above, it is, preferable to be~~ preferably, positioned in a region where the heat generating density is smaller than ~~an averaged~~ the average heat generating density of the chip as a whole, for the purpose of decreasing an ill-adverse influences ~~receiving from~~ caused by heat generation of the integrated circuit device, ~~of~~ being the semiconductor chip 101. In the present embodiment, ~~it the driving means~~ is formed in a region, ~~being region~~ close to an end of the integrated circuit board 1. Alternately ~~Alternately~~, it may be provided ~~corresponding to~~ at a portion of the integrated circuit board where the memory is formed, in which the heat generation is relatively small.

~~Also, in these~~ In Figs. 5(A) and 5(B), ~~also,~~ a reference numeral 7 ~~is represents~~ temperature sensors for detecting the hot spot generated in the integrated circuit board 1, of being the semiconductor chip 101. Each temperature sensor is represented by, and in more details thereof, each being formed to be a resistor layer formed on a lower layer of the electronic circuit layer 2. Namely, it is possible to detect the position where the hot spot is generated (in more details ~~detail~~, at which ~~position positions~~ in the vertical direction of the integrated circuit board shown in Fig. 5(B)), by measuring the change of the resistance value of the temperature sensors 7. In the present embodiment, there is disclosed an example, ~~showing these where those~~ temperature sensors 7 ~~are to be~~ located at about a center of the board 1 mentioned above, while forming them alighting to the positions where the plural number ~~plurality~~ of the passage ducts 3 are formed, and

~~directing in the~~ the temperature sensors being aligned in a direction orthogonal to the extension direction of the passage ducts 3. ~~thereto, on one line.~~ However, according to the present invention, it should not be restricted only to that mentioned above.

5 For example, ~~however it is also possible to provide~~ arrange the plural number plurality of these passage ducts 3, ~~for example,~~ differently along a plane of the integrated circuit board 1 mentioned above (i.e., forming a different dispersion pattern ~~them~~ dispersing on the plane), as deemed appropriately appropriate.

10 Next, Fig. 1 ~~attached herewith of the drawings~~ is a partial enlarged cross-section view ~~for showing the cross-section of an end portion, expansively, on which the resistor films 5 are formed for building up the driving means of the operating fluid, in the passage ducts 3 formed in the integrated circuit board 1, of being~~ the semiconductor chip 101. However, in this figure, ~~being different from~~ unlike the structure shown in Figs. 5(A) and 5(B) ~~mentioned above,~~ there is shown an example where the resistor films 5 for building up the driving means of the operating fluid are formed on the lower side surface of the passage ducts 3 mentioned

15

20 above, in the figure.

As is apparent from the figure, the integrated circuit board 1, ~~of being the semiconductor chip 101,~~ comprises the electronic circuit (forming) layer 2, on the lower surface side ~~surface~~ of which ~~the a large number of~~ a large number of circuits are formed ~~in the large number thereof,~~ for building up the logic element (i.e., the CPU) and the memory element (i.e., the memory) within the same chip. On the other hand, ~~upon~~ on the upper side surface of the integrated circuit board 1 (i.e., the side opposing to the surface side, on which the electronic circuit layer 2 is formed) is laminated a

25

30 resistor layer 12 (such as, a layer made of polysilicon, tantalum compound (TaN), etc., for example), for forming the resistor films 5, which builds up the driving means of the operating fluid, through an insulating layer 11 (such as, a layer of SiO<sub>2</sub>, for example).

Further, ~~upon~~ on the upper surface are formed metal layers 13 on both sides of this resistor layer 12, so as to form wiring for supplying the resistor layer 12 with electric power, and further upon the upper surface thereof is formed a protection layer 14.

5 And, further, on ~~upon~~ the upper surface thereof, a flow passage (or heat diffusing) layer (or substrate) 15 is connected with the integrated circuit board 1, integrated in one body, which is made from a silicon plate, being the same material as that of ~~to the integrated circuit board 1 mentioned above in the material thereof.~~

10 Further, on the lower surface of the silicon plate for building up the flow passage (or heat diffusing) substrate 15, there are formed the passage ducts 3 and the buffer 6 mentioned above, which are in the plural in number thereof, in advance, via a machining technology, such as, a dry etching, etc., for example, and this  
15 flow passage substrate 15 is connected with the integrated circuit board 1, forming in one body.

Charging of the operating fluid is carried out, by charging a liquid, such as, a water, etc., as the operating fluid 4, into an inside of the plural passage ducts 3 ~~in the plural number thereof~~  
20 and/or the buffer 6 ~~mentioned above~~, for example, when connecting the flow passage substrate 15 onto the integrated circuit board 1 in one body. Or, alternately, though not shown in the figure herein, with provision of ports for communicating between the surfaces of the passage ducts 3 and the semiconductor chip 101,  
25 the operating fluid 4 may be charged into therefrom. Upon the charging of the operating fluid 4, the charging pressure may be changed, or a gaseous portion (i.e., an air) of non-condensable gas is mixed with when charging, depending upon the characteristics of that operating fluid 4.

30 Also, the material for forming the flow passage substrate 15 ~~mentioned above~~ should not be restricted only to the silicon, but may also ~~may be~~ a material having ~~the a~~ thermal expansion coefficient ~~being~~ similar to that of ~~the~~ silicon. Also, the protection layer 14, mentioned above, is provided for the purpose

of protecting the ~~said~~ resistor layer 12 from contacting with the operating fluid 4, such as ~~of the~~ water, etc., directly; however, it may be unnecessary depending upon selection of the materials of ~~these~~ the resistor layer and the operating fluid.

5        As to the size of the semiconductor chip (i.e., the chip-die) that is mounted on the semiconductor circuit device 100, according to the present invention, mentioned above, it may be assumed to be ten (10) mm to several tens mm. On, ~~on the contrary to this~~ other hand, the cross-section of the passage duct may have a cross-section  
10    ~~aria~~ area of ten (10)  $\mu$ m square to a hundred (100)  $\mu$ m square.

Also, though not shown in the figure herein, there is ~~provide~~ provided a means for supplying the electric power to the resistor layers 12, through the wiring made ~~up~~ with the wiring of ~~these~~ the metal layers 13, mentioned above, but in an intermittent or  
15    a pulse-like manner. The pulse frequency, in this instance, though depending upon the kind of ~~the~~ operating fluid 4 used and the size of the passage ducts 3, is about from several tens Hz to several hundreds Hz. As such the pulse electric power supply means, ~~it~~ may be formed on the electronic circuit layer 2 of the integrated  
20    circuit board 1, or it may be built up with the logic element, such as the CPU, formed within the forming surface of the electronic circuit layer 2. Further, though not shown in the figure, it is also possible to utilize a portion of the electric power from a power source for supplying the driving power to the semiconductor  
25    integrated circuit device 100 according to the present invention (more specifically, in more details thereof, a portion of the electric power may be supplied to the integrated circuit board 1 though the external terminals mentioned above), and as such the structure is advantageous from a viewpoint of simplification on  
30    circuitry thereon.

~~Following~~ In supplement to the above, explanation will now be given in more ~~details~~ detail about the transferring (diffusing) function of the heat generation in the integrated circuit board

1, the detailed structure of which was explained ~~in the above~~, by referring to Fig. 1 ~~mentioned above~~, and Figs. 5(A) and 5(B).

First, when the electric power is supplied, in the pulse-like manner, from the pulse electric power supply means mentioned above, the resistor layer 12, shown in Fig. 1, ~~mentioned above~~ generates heat, and then the operating fluid 4 (for example, it is ~~the water~~, in the present example) within the passage duct 3 is heated abruptly (i.e., the pulse-like manner), and thereby being evaporated (i.e., generating the bumping) to generate bubbles of vapor 4a thereof within the operating fluid 4. Thereafter, when stopping the electric power supply of the pulse-like manner, the heat generation is also stopped by means of the resistor layer 12, and the generated operating fluid vapor 4a ~~mentioned above~~ disappears.

Further, the protection layer 14 is necessary herein, also, for the purpose of protecting the resistor layer 12 from being damaged through the cavitations function, which is generated when the vapor 4a disappears. In this manner, supplying the pulse-like electric power to the resistor layers 12, intermittently, brings the operating fluid 4 enclosed inside to repeat the generation and expiration of the bubbles due to the vapor 4a of the operating fluid at the end portion within the inside of the passage ducts 3. And then, when the operating fluid 4 is boiled suddenly (i.e., generating the bumping), vibration is generated due to expansion of the bubbles and following an abrupt increase of pressure accompanying with the evaporation thereof. This vibration generated drives the operating fluid 4. Namely, accompanying the vibration of the operating fluid 4 within the passage ducts 3, the heat generated in the electronic circuit layer 2 of the integrated circuit board 1 (in particular, the local increase of temperature, such as, the hot spot) can be transferred (or diffused) (see the arrows shown in Figs. 5(A) and 5(B)), thereby averaging or flattening the temperature distribution within the integrated circuit board 1 and also suppressing the generation of the local increase of temperature.

~~Also, in~~ In the integrated circuit board 1 mentioned above, also, the passage ducts 3 are provided in ~~the plural number a~~ plurality thereof and in parallel to one another, on the upper surface side ~~surface~~ of the board, and, further, each of the passage  
5 ducts 3 is constructed, so that it can be driven and/or operated, individually or independently. Then, the pulse-like electric power supply means, mentioned above, detects the position of the local increase of temperature by using temperature detection signals from the temperature sensors 7, which are disposed within the board,  
10 thereby enabling to control the driving electric power to be supplied to the passage ducts 3, selectively. Namely, the pulse-like electric power is supplied (or drives), intermittently, only to the resistor layer(s) 12 of the passage duct(s) 3 corresponding to the portion(s) where the local increase of  
15 temperature, such as, the hot spot, is generated in the electric circuit layer 2 of the integrated circuit board. With this, it is possible to obtain the heat transfer (or diffusion), not as a whole of the board, but only the portion where it is necessary; therefore, it is possible to achieve the heat transferring (or  
20 diffusion) function in the integrated circuit board 1, with very much high efficiency.

However, in the embodiment mentioned above, ~~the explanation the description was given only on for the example where the plurality~~ of passage ducts 3 are formed in ~~the plural number thereof,~~ only  
25 one direction (i.e., arranged in the vertical direction shown in Fig. 5(B) ~~mentioned above~~) but are extended in parallel to one another, on the upper surface side ~~surface~~ of the integrated circuit board 1. ~~But~~ However, the present invention should not be restricted only to that, and it may be also possible to form a layer of the  
30 plural ~~number of~~ passage ducts 3, which are formed in the horizontal direction in Fig. 5(B) ~~mentioned above~~ and are in parallel to one another, further onto any one of the upper and lower layers thereof, in addition to the plurality of passage ducts ~~of the plural number~~ being formed in the vertical direction and extended in parallel  
35 to one another. Namely, with such ~~the a~~ structure, in particular,

when ~~disposing~~ dispersing the temperature sensors 7, ~~dispersedly~~, within the plane surface of the board, it is possible to select the passage ducts 3 to be driven and/or controlled, in a sense of a plane (i.e., not only in the vertical direction, but also in the horizontal direction), with using the temperature detection signals from those temperature sensors 7, thereby achieving the a heat transferring (diffusion) function of much higher efficiency.

~~Also, with~~ With the embodiment mentioned above, though the a description was ~~made~~ given only on the structure for selecting the passage ducts 3 to be driven ~~with~~ by using the detection signals of the temperature sensors 7, ~~however it~~ It is also possible to select and/or control the passage duct(s) 3 to be driven, but, however, without provision of such ~~the~~ temperature sensors 7 within the integrated circuit board 1, as was mentioned above, for example, by calculating (or predicting) the heat generating portion on the ~~upon~~ basis of the control signals to the CPU (i.e., being the portion of large heat generation), which is formed within the electronic circuit layer 2 of the integrated circuit board 1. With such ~~the~~ a structure, since ~~no~~ such ~~the~~ temperature sensor 7 is unnecessary ~~necessary~~, therefore it is possible to achieve the heat transfer (or diffusion) function with high efficiency, but with a relatively simple structure thereof, therefore making this it ~~may be~~ advantageous from an economical viewpoint.

According to the embodiment mentioned above, on one surface of the integrated circuit board 1, being the semiconductor chip 101 building up the semiconductor integrated circuit device 100, the electronic circuit layer 2 is formed, on which are formed the circuit elements accompanying the local increase of temperature, such as, the hot spot, representatively, while on the side, opposing to that where the electronic circuit layer 2 is formed, there are formed the layer 15 for achieving the function of transferring (or diffusing) the heat generated within the electronic circuit layer 2 (such as, the flow passage layer (or substrate), in which the passage ducts are formed in the plural number thereof, for

example), as well as, the resistor layer 12 to be the heating/driving means, in one body, made of the same type of material being same to that of the integrated circuit board (such as, the silicon, used in the present example, for example). For this reason, the heat generated within the integrated circuit board 1, ~~of~~ being the semiconductor chip 101, can be transferred (or diffused) with high efficiency, within an inside of the board. Therefore, ~~and therefore~~ it is possible to suppress or eliminate the local increase of temperature, greatly, such as, the hot spot, representatively, which is caused due to the difference in the electric power density, even in the semiconductor chip applying the "System On Chip" mentioned above therein.

Furthermore, accompanying the description in the above, with the integrated circuit package, in which such the semiconductor chip is mounted, there is no necessity to set a permissible temperature thereof to be a low value when setting it, by taking the local increase of temperature into ~~the~~ consideration. ~~and therefore~~ Therefore, it can be used under the condition of relatively high permissible temperature. Namely, when installing it into an appliance, the integrated circuit package can be used under the condition of relatively high permissible temperature, with ease. ~~for~~ For example, this can be done by simply by only attaching such ~~the~~ heat sink as was mentioned in the above thereto, but without accompanying with an improvement and/or high efficiency on the cooling performance for the integrated circuit package, nor large-sizing or scaling of the cooling structure thereof. Also, it is, of course, possible to be applied, in particular, into a small-sized computer and/or small-sized electronics, being necessary to be necessarily portable, such as, ~~those being called~~ by of the "desk top" and/or the "note size", for example, and, also, into ~~the~~ computers being called ~~by~~ the "rack-rack mount server" and/or the "blade server", installing in which the integrated circuit packages in a ~~plural number~~ plurality thereof with high density therein are installed.

Also, as was mentioned in the above, the flow passage layer (or the substrate) ~~16~~15, in which the passage ducts 3 are formed in ~~the plural number~~ a plurality thereof, is made of ~~the a~~ material (such as, the silicon, in the present example, for example), ~~being~~ which is the same to that of the integrated circuit board 1, or is of the a material ~~being~~ close to that in the thermal expansion coefficient thereof, integrated in one body, and it is superior in the strength against ~~the~~ stress due to the heat generated repetitively within the integrate circuit board 1. Therefore, and ~~therefore,~~ it is possible to protect the integrate circuit board, with certainty, from an accident of leakage of the water enclosed within the passage ducts 3, which is a fatal to the electronic circuitry, and, in particular, caused by the breakage of connection portion due to such the stress thereon. Namely, it is possible to provide ~~the a~~ semiconductor integrated circuit device equipped with the heat transfer (or diffusion) function, ~~being~~ which is superior in safety.

Furthermore, with the integrated circuit board 1, ~~of being~~ the semiconductor chip 101 according to the present embodiment mentioned above, in particular, the insulating film 11, the resistor layer 12, the metal films 13 for use of wiring, and the protection layer 14 are formed, ~~piling up one another one~~ the other, on the surface ~~side surface~~ opposing to that on which the electronic circuit layer 2 of the board is formed, and then the flow passage layer (or the substrate) 15 is attached thereto, in which the plural passage ducts 3 are formed, in the structure thereof; i.e., it can be manufactured and achieved with ease, by applying the ordinary manufacturing technologies of the integrated circuit board, therefore it is advantageous from the economical viewpoint thereof.

Next, Figs. 6 and 7 ~~attached herewith~~ of the accompanying drawings show other ~~example~~ examples ~~about~~ of the passage duct 3 formed in the flow passage (or the heat transfer) layer (or the substrate) 15, building up the integrated circuit board 1 according

to the present invention. Thus, the passage duct 3 shown in Fig. 6 is one (1) piece, and is one example of forming it in zigzag manner, winding around over the entire surface of the substrate. However, as is shown in the figure, the resistor film 5 is provided  
5 at the left-hand side in an upper portion in the figure, and also the buffer 6 is formed at the position opposing to where the resistor film 5 is formed (i.e., the lower side in the shown figure 6).

Also, in Fig. 7, the passage duct 3 formed therein is only one (1) piece, as well as, winding around over the entire surface  
10 of the substrate in the zigzag manner, however both end portions thereof are connected with each other, thereby being ~~in~~ circular-like in the shape thereof, as a whole. However, in the example of this figure, the resistor film 5 building up the driving means is provided at a central portion on the right-hand side in  
15 the figure, while the buffer 6 is formed at ~~the a~~ position opposing to where the resistor film 5 is formed (i.e., the left-hand side in the figure).

Thus, in ~~those~~ these other examples ~~in relation with~~ regarding the passage duct 3, since the passage duct 3 is only  
20 one (1) piece, and also the resistor film 5 is only one (1) set, for building up the driving means thereof, it can be manufactured, easily. Therefore, ~~therefore~~ it is suitable for providing the integrated circuit board ~~being to be~~ relatively small in sizes size and, also, inexpensive. ~~cheap in the price.~~

25 As ~~was~~ should be fully apparent from the detailed description given ~~in the~~ above, according to the present invention, it is possible to achieve the semiconductor integrated circuit device and also the semiconductor integrated circuit chip for it, enabling the small-size and/or light-weight of the cooling structure thereof,  
30 while lowering and suppressing the differences in the thermal distribution, such as, the hot spot generated within the semiconductor chip, representatively, with certainty, accompanying the small-sizing of the chip and/or application of

the System On Chip, but without reducing the permissible temperature of the integrated circuit package, in which the semiconductor chip is mounted.

The present invention may be embodied in other specific forms without departing from the spirit or essential feature or characteristics thereof. The present embodiment(s) is/are, therefore, to be considered in all respects as illustrative and not restrictive, the scope of the invention being ~~indicated~~ defined by the appended claims rather than by the forgoing description and range of equivalency of the claims are therefore to be ~~embraces~~ embraced therein.